



520.41003X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KIMURA, et al.
Application No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE MANUFACTURING METHOD OF THE
SAME, SEMICONDUCTOR DEVICE AND ELECTRONIC
DEVICE
Art Unit: 2813
Examiner: L. M. Schillinger

REPLY TO NON-FINAL OFFICE ACTION

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 18, 2006

Sir:

In response to the non-final Office Action, dated April 18, 2006, the period of response for which extension is requested by the attached Petition for Extension of Time, please enter the responsive Remarks as listed below and as set forth on the following pages:

Remarks are included beginning on the following page.

(Appendix A is included following the Remarks.)